

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

licant :

Ohtani, et al.

Art Unit :

2815

Serial No.:

09/455,991

Examiner :

Jose R. Diaz

Filed

December 6, 1999

Title

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

THE SAME

Commissioner for Patents Washington, D.C. 20231

TRANSMITTAL LETTER AND PETITION FOR AUTOMATIC EXTENSION

Correspondence relating to this application is enclosed. The required fees are computed below. Please apply any charges not covered, or any credits, to Deposit Account No. 06-1050.

Total

17 Claims 2

2

17

\$0

Independent

. 0

\$0

TOTAL FEE DUE

\$0

Respectfully submitted,

Date: 10/18/01

James T. Hacler Reg. No. 40,631

Fish & Richardson P.C.

PTO Customer No. 20985

4350 La Jolla Village Drive, Suite 500

San Diego, California 92122 Telephone: (858) 678-5070 (858) 678-5099 Facsimile:

10141023.doc

CERTIFICATE OF MAILING BY FIRST CLASS MAIL I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231. 10/18/2001

Date of Deposit

Signature

Debbrah K. Sim

Person Printed Name οf Typed or Certificate





Attorney's Docket No.: 07-213002 / US3521/3522

9/Bollesa

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :

Ohtani, et al.

Art Unit :

2815

Jose R. Diaz

Serial No.:

09/455,991

Examiner:

Filed

December 6, 1999

Title

SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

THE SAME

BOX AF

Commissioner for Patents Washington, D.C. 20231

RESPONSE

In response to the action mailed July 18, 2001, please amend the application as follows:

In the claims:

Please amend claim 6 as follows:

6. (Amended) A method of manufacturing a

semiconductor device, said method comprising:

forming an amorphous semiconductor film on an

insulating surface;

introducing a metal element being capable of promoting crystallization of the amorphous semiconductor film to

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

Date of Deposit

10/18/2001

Signature

Debbrah K. Sim

Typed or Printed Name of Person Signing Certificate

B